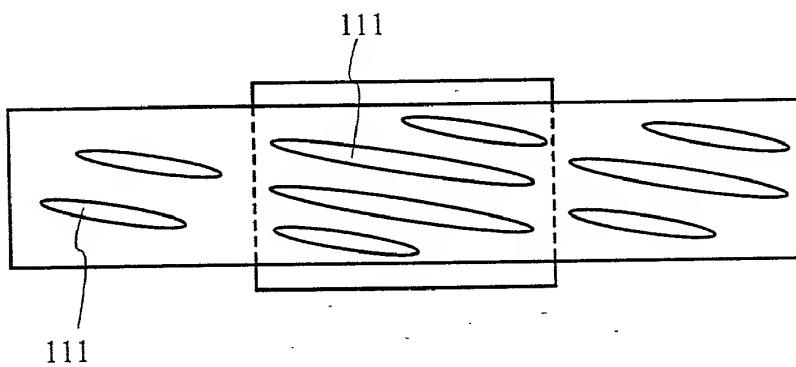


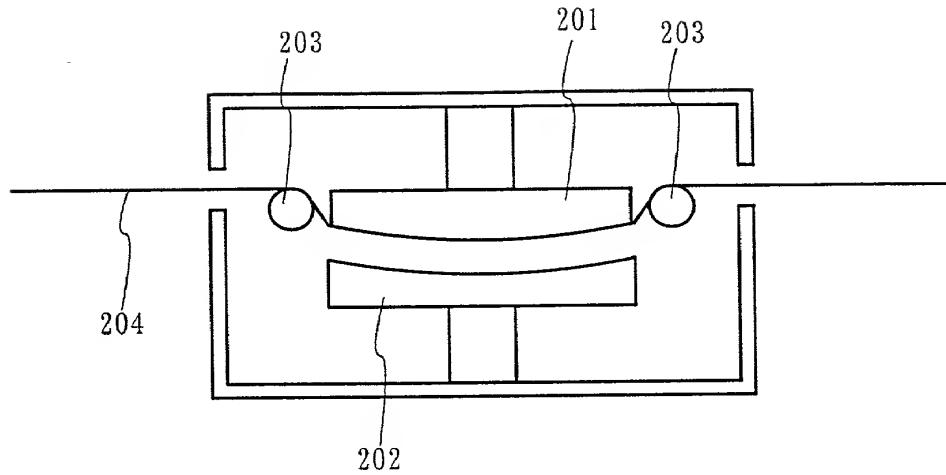
PRIOR ART

FIG. 1A



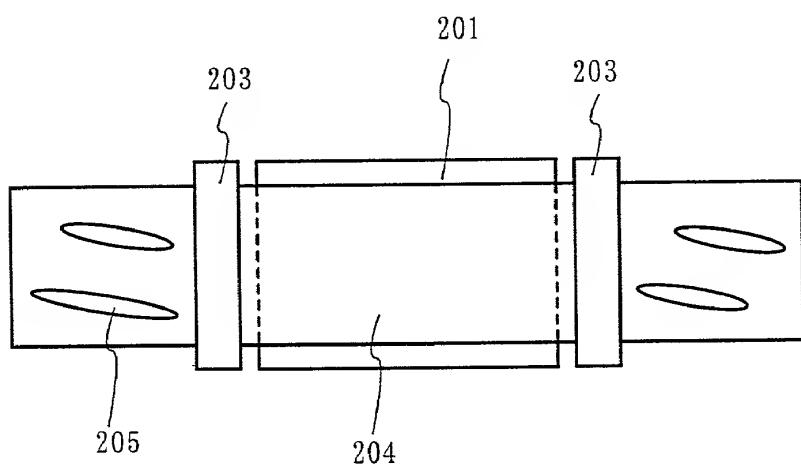
PRIOR ART

FIG. 1B



PRIOR ART

FIG. 2A



PRIOR ART

FIG. 2B

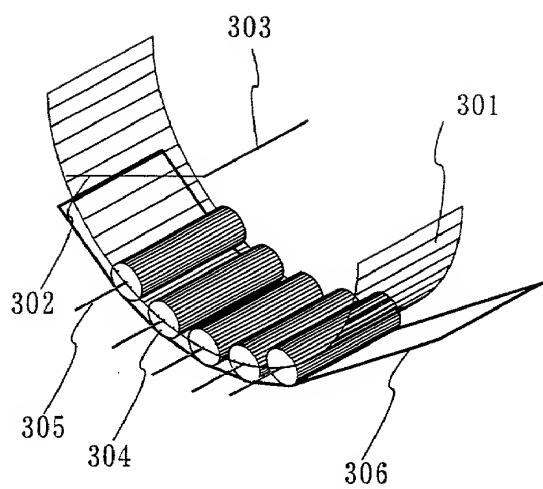


FIG. 3

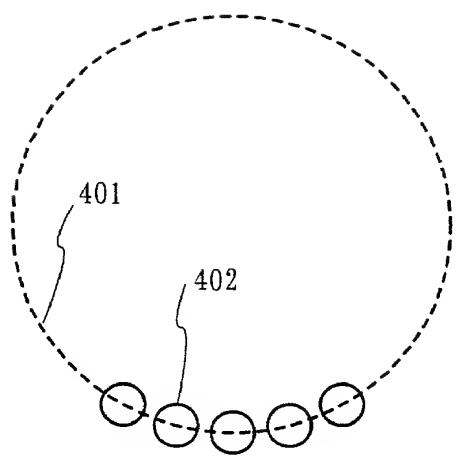


FIG. 4A

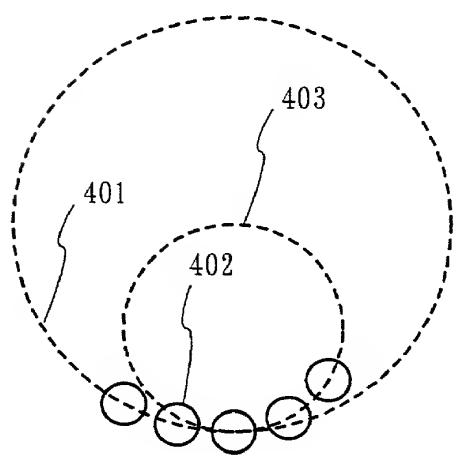


FIG. 4B

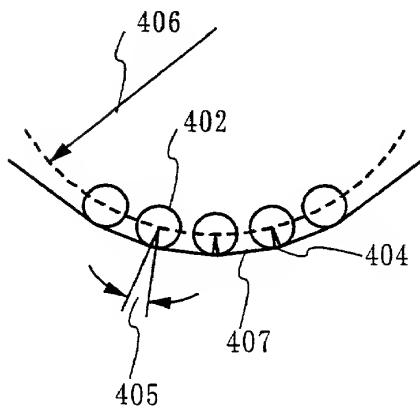


FIG. 4C

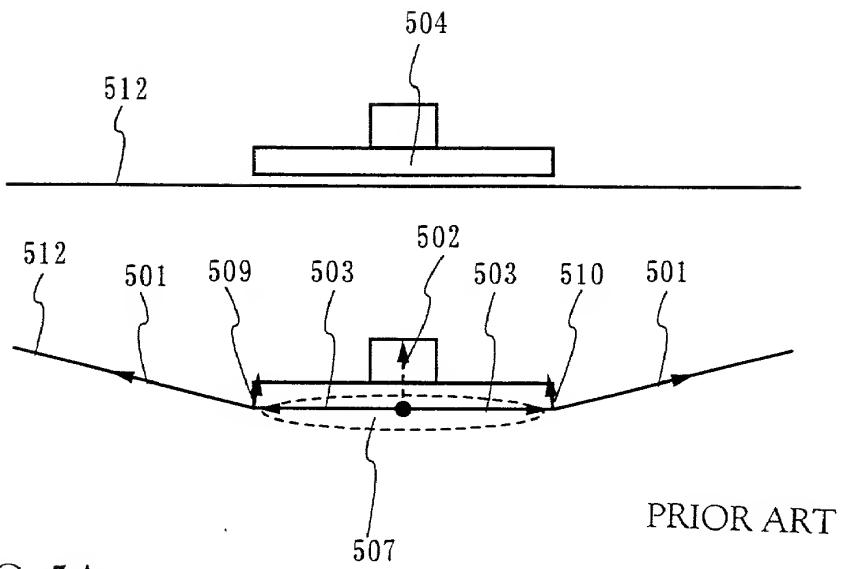


FIG. 5A

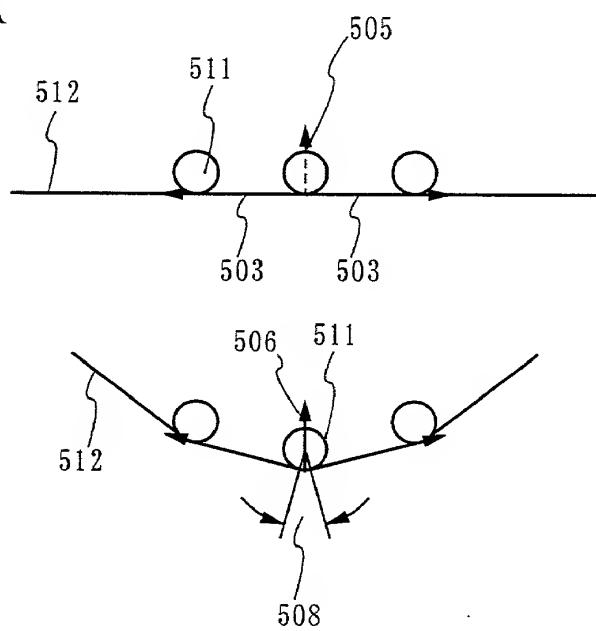


FIG. 5B

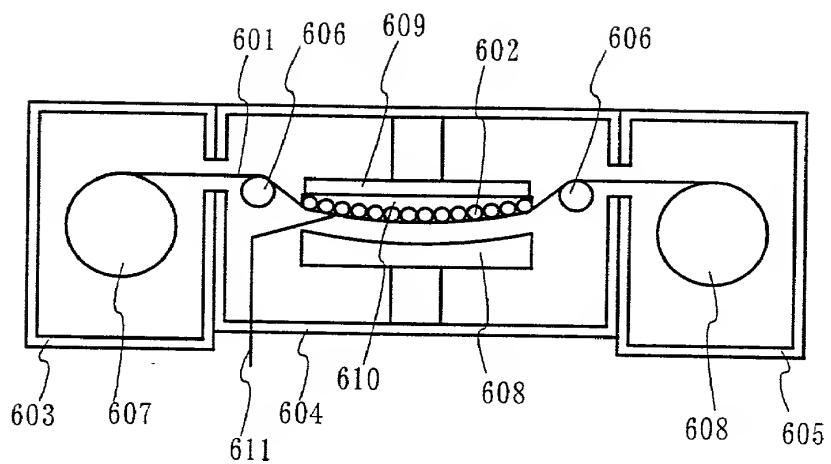


FIG. 6A

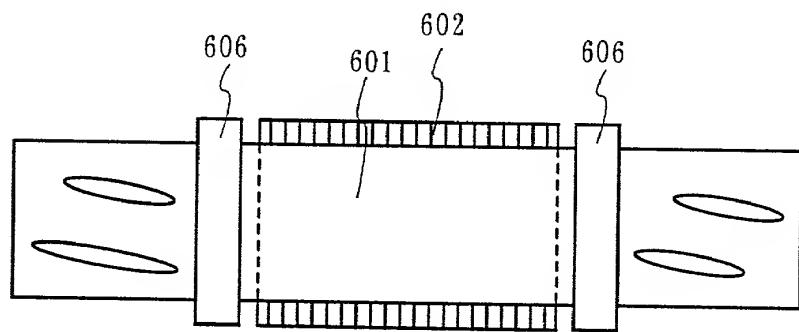


FIG. 6B

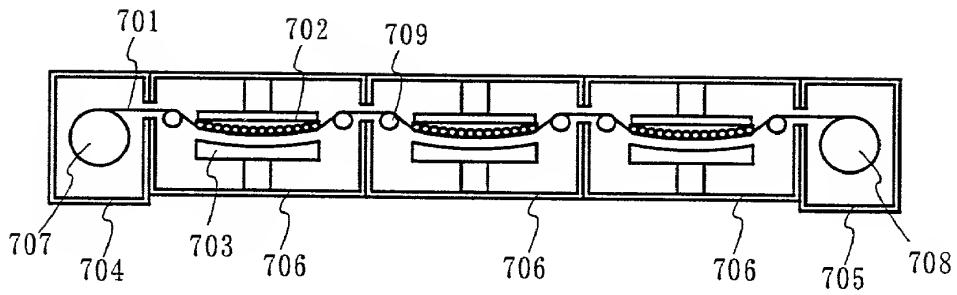


FIG. 7A

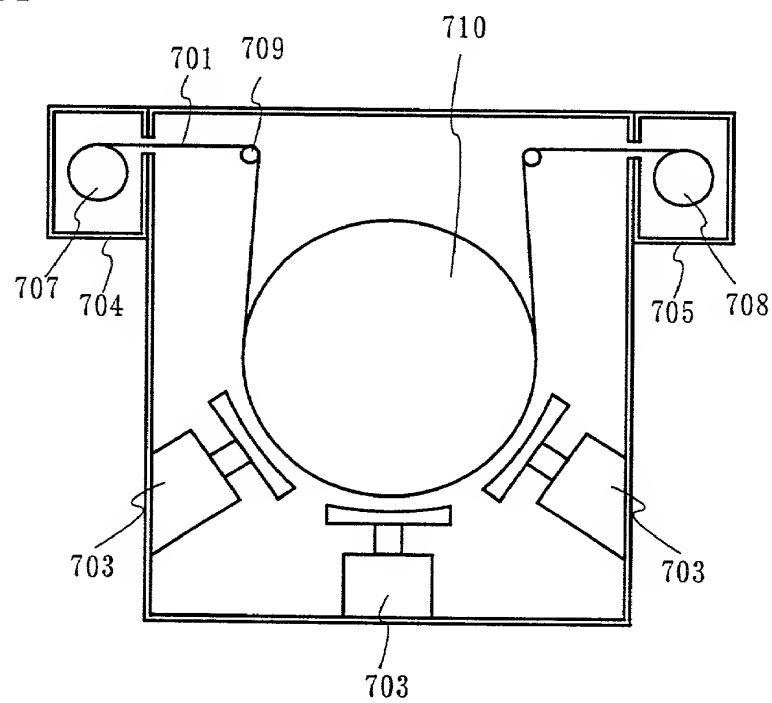


FIG. 7B

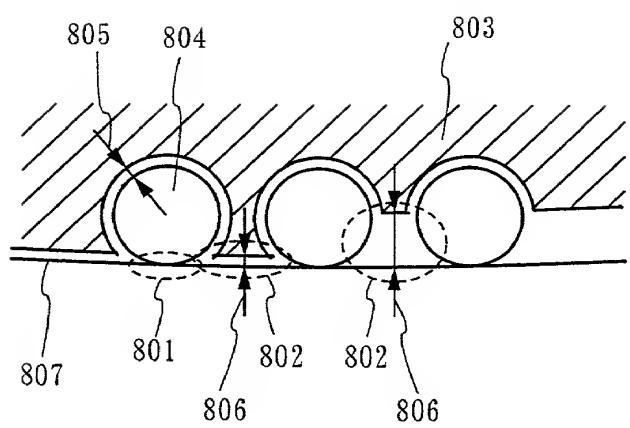


FIG. 8

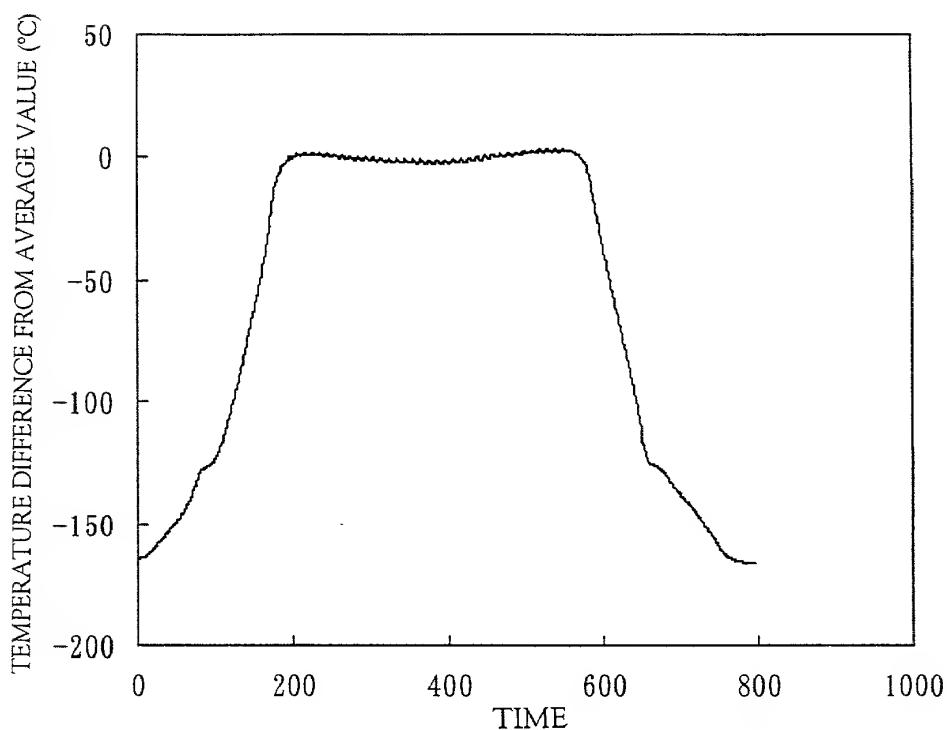


FIG. 9A

MEASUREMENT OF TEMPERATURE OF
CURVED SURFACE ROLLER METHOD ELECTRODE

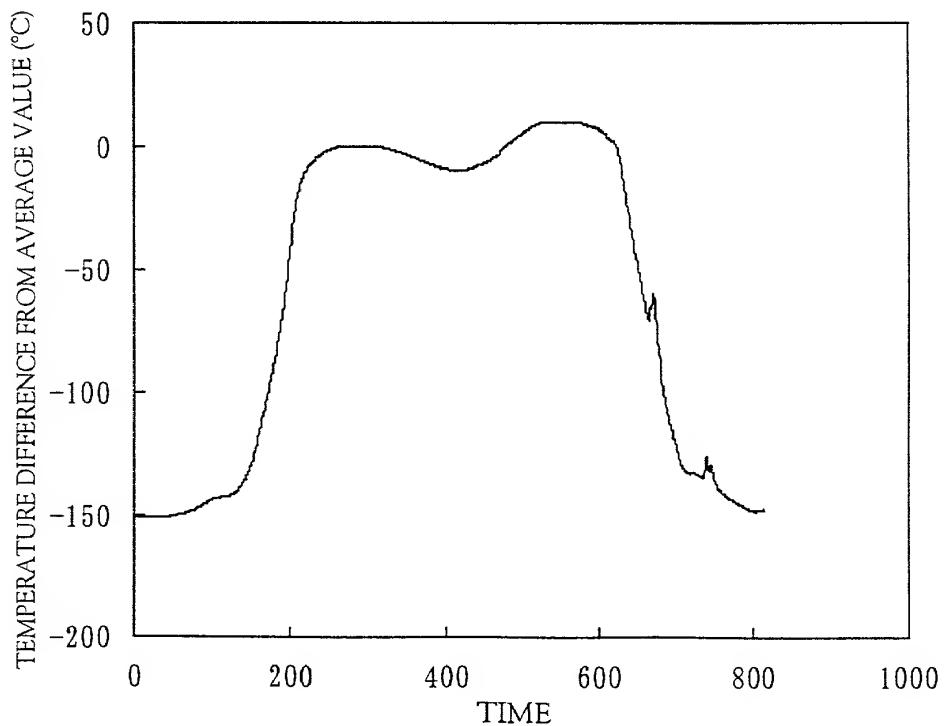


FIG. 9B

MEASUREMENT OF TEMPERATURE OF
PARALLEL PLATE METHOD ELECTRODE

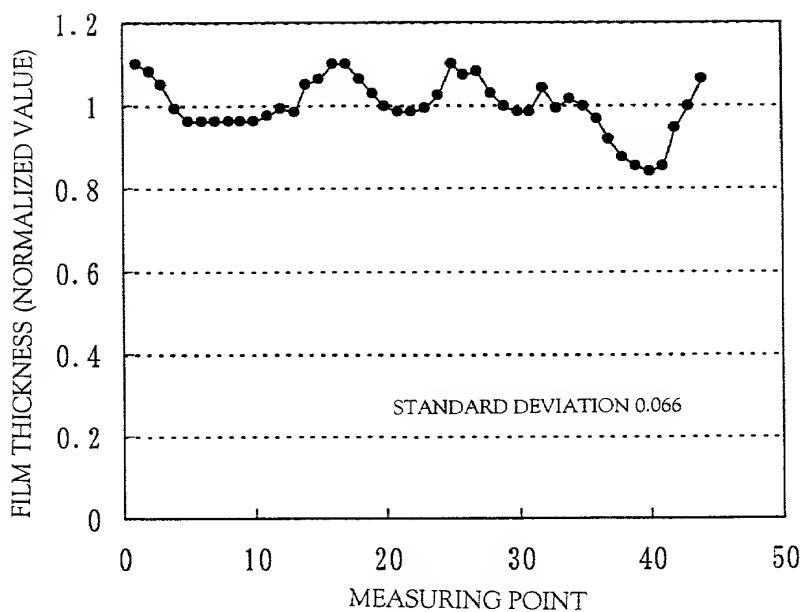


FIG. 10A

FILM FORMATION WITH PARALLEL PLATE METHOD ELECTRODE AND
MEASUREMENT OF FILM THICKNESS IN SUBSTRATE WIDTH DIRECTION

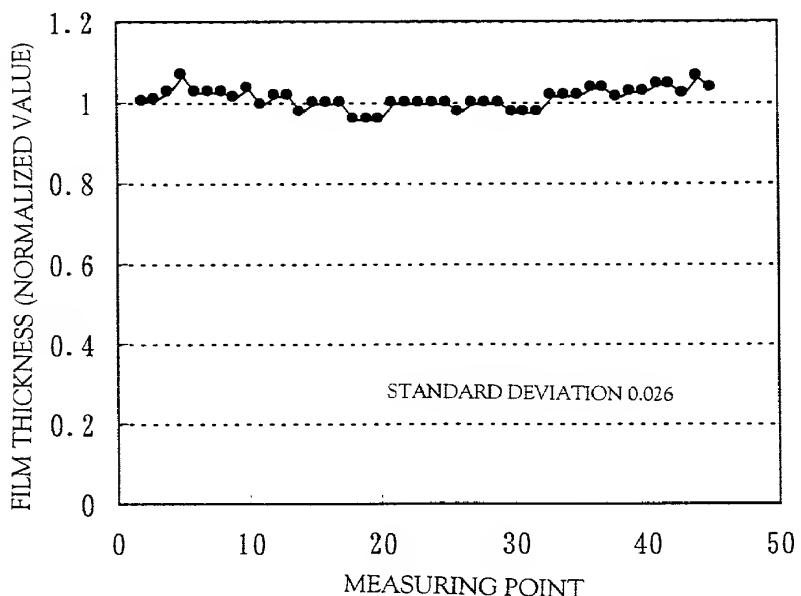


FIG. 10B

FILM FORMATION WITH CURVED SURFACE ROLLER METHOD ELECTRODE AND
MEASUREMENT OF FILM THICKNESS IN SUBSTRATE WIDTH DIRECTION